

Patent



IPW

Customer No. 31561
Application No.: 10/708,209
Docket No. 11583-US-PA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicant : Kuo et al
Application No. : 10/708,209
Filed : February 17, 2004
For : THIN FILM TRANSISTOR ARRAY SUBSTRATE AND
PHOTOLITHOGRAPHY PROCESS AND DESIGN OF THE
MASK THEREOF
Examiner :
Art Unit : 2871

ASSISTANT COMMISSIONER FOR PATENTS
Arlington, VA22202

Dear Sirs:

Transmitted herewith is a certified copy of Taiwan Application No.:
092122605, filed on: 2003/08/18.

A return prepaid postcard is also included herewith.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property Office

Dated: July 5, 2004

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